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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of : Frank Randolph Bryant  
United States Serial No. : to be assigned  
Filing Date : to be assigned  
Prior United States Serial No. : 08/159,461  
Prior Filing Date : November 30, 1993  
Prior Examiner : R. Booth  
Prior Group Art Unit : 1107  
Title : TRANSISTOR STRUCTURE AND METHOD FOR  
MAKING SAME  
Assistant Commissioner for Patents  
Box Patent Application  
Washington, D. C. 20231

Dear Sir:

CERTIFICATE OF MAILING

Express Mail Certificate No. EL 749594003 US

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Box Patent Application, Washington, D.C. 20231, on May 16, 2001.

KATHY LONGENECKER  
(Printed or typed name of person signing the certificate)  
*Kathy Longenecker*  
(Signature of the person signing the certificate)

INFORMATION DISCLOSURE STATEMENT

Pursuant to the duty of disclosure under 37 C.F.R. § 1.56, Applicant submits this statement. This submittal is made in accordance with 37 C.F.R. §§ 1.97 and 1.98 and § 609 of the Manual of Patent Examining Procedure. The patents, publications and other information herein are listed below and on the attached Form PTO-1449. Copies of the listed references are submitted herewith.

U.S. Patent No.

Inventor

Date

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Publications

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K. Nomura, et al., "Enhanced Oxidation of Silicon by Ion Implantation and its Novel Applications," 1974, pp. 681-688.

Applicant hereby expressly reserves the right to swear behind the effective dates of any of the above Patents and to question the relevance and materiality of the Patents and Publications listed herein, in whole, in part, or in combination, subsequent to filing this Information Disclosure Statement.

Respectfully submitted,

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Date: 5-16-01



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